

10/555141

JC20 Rec'd PCT/PTO 31 OCT 2005

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group
Art Unit: Unknown

Attorney
Docket No.: RAC0082

Applicant: Alexander HAUSER et al.

Invention: METHOD FOR TEXTURING
SURFACES OF SILICON WAFERS

Serial No.: Unknown
Filed: Herewith

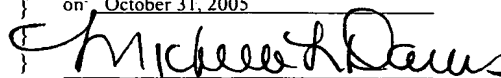
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Examiner: Unknown

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PRELIMINARY AMENDMENT

Box: PCT
Attn: DO/EO/US
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to the examination of the above-identified application, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.